

55/205



		<b>Subclass</b>	<b>ISSUE CLASSIFICATION</b>
	<b>Class</b>		

**PATENT NUMBER**

**U.S. UTILITY Patent Application**

O.I.P.E.

**PATENT DATE**

APPLICATION NO.	CONT/PRIOR:	CLASS 134	SUBCLASS 77	ART UNIT 1746	EXAMINER <i>CHIN COLE</i>
APPLICANTS Jong-Woon Oh Dong-Jun You Ju-Sang Byun Seung-Hoon Kong					
TITLE Cleaning apparatus for semiconductor wafer					

PTO-2040  
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## **ISSUING CLASSIFICATION**

Continued on Issue Slip Inside File Jacket

TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.				<b>NOTICE OF ALLOWANCE MAILED</b>	
<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S Patent. No. _____				<b>ISSUE FEE</b>	
				Amount Due	Date Paid
<input type="checkbox"/> The terminal ____ months of this patent have been disclaimed.				<b>ISSUE BATCH NUMBER</b>	
				(Legal Instruments Examiner)	(Date)

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